## DOCKET 1077

## What is claimed is:

- 1. A laminated semiconductor article comprising:
  - a. a flexible substrate;
  - b. a biaxially textured Ir-based buffer layer over said flexible substrate; and
  - c. at least one epitaxial layer of a semiconductor over said Ir buffer layer.
- 2. A laminated semiconductor article in accordance with claim 1 wherein at least a portion of said substrate comprises at least one of the group consisting of stainless steel, Cu, Ni, Fe, Al, Ag, and alloys of any of the foregoing.
- 3. A laminated semiconductor article in accordance with claim 1 wherein at least a portion of said substrate comprises at least one of the group consisting of Ni-W, Ni-Cr, Ni-Cr-W, Ni-Cr-Al, Ni-W-Al, Ni-Cr-V, Ni-V, and Ni-Mn.
- 4. A laminated semiconductor article in accordance with claim 1 wherein at least a portion of said article comprises a buffer system between the Ir-based buffer layer and said semiconductor, said buffer system comprising at least one material selected from the group consisting of nitrides, perovskites, MgO, CeO<sub>2</sub>, Y<sub>2</sub>O<sub>3</sub>, SrTiO<sub>3</sub>, BaZrO<sub>3</sub>, BaSnO<sub>3</sub>, BaCeO<sub>3</sub>, YSZ, (RE<sub>1-x</sub>Sr<sub>x</sub>)MnO<sub>3</sub>, REMnO<sub>3</sub>, RE<sub>2</sub>O<sub>3</sub>, REAlO<sub>3</sub>, RE<sub>2</sub>Zr<sub>2</sub>O<sub>7</sub>, RE<sub>3</sub>NbO<sub>7</sub>, RESMO, and REMO where RE comprises at least one rare-earth element.
- 5. A laminated semiconductor article in accordance with claim 1 wherein at least a portion of said flexible substrate is characterized by at least one of the group of characteristics consisting of single crystal, biaxially textured, and untextured.
- 6. A laminated semiconductor article in accordance with claim 1 wherein said Ir buffer layer further comprises the alloy Ir<sub>1-x</sub>M<sub>x</sub> wherein M comprises at least one element selected from the group consisting of Ta, Ti, Cu, Pt, Pd, Ru, Rh, Os, Au, W, and Ag.
- A laminated semiconductor article in accordance with claim 1 wherein said semiconductor comprises diamond.

- 8. A laminated semiconductor article comprising:
  - a. a flexible substrate;
  - b. a biaxially textured buffer system on said flexible substrate;
  - c. an epitaxial Ir-based buffer layer on said buffer system; and
  - d. at least one epitaxial layer of a semiconductor over said Ir buffer layer.
- 9. A laminated semiconductor article in accordance with claim 8 wherein at least a portion of said substrate comprises at least one of the group consisting of stainless steel, Cu, Ni, Fe, Al, Ag, and alloys of any of the foregoing.
- 10. A laminated semiconductor article in accordance with claim 8 wherein at least a portion of said substrate comprises at least one of the group consisting of Ni-W, Ni-Cr, Ni-Cr-Al, Ni-W-Al, Ni-Cr-W, Ni-Cr-V, Ni-V, and Ni-Mn.
- 11. A laminated semiconductor article in accordance with claim 8 wherein at least a portion of said article comprises another buffer system between the Ir-based buffer layer and said semiconductor, said another buffer system comprising at least one material selected the group consisting of nitrides, perovskites, MgO, CeO<sub>2</sub>, Y<sub>2</sub>O<sub>3</sub>, SrTiO<sub>3</sub>, BaZrO<sub>3</sub>, BaSnO<sub>3</sub>, BaCeO<sub>3</sub>, YSZ, (RE<sub>1-x</sub>Sr<sub>x</sub>)MnO<sub>3</sub>, REMnO<sub>3</sub>, RE<sub>2</sub>O<sub>3</sub>, REAlO<sub>3</sub>, RE<sub>2</sub>Zr<sub>2</sub>O<sub>7</sub>, RE<sub>3</sub>NbO<sub>7</sub>, RESMO, and REMO where RE comprises at least one rare-earth element.
- 12. A laminated semiconductor article in accordance with claim 8 wherein at least a portion of said flexible substrate is characterized by at least one of the group of characteristics consisting of single crystal, biaxially textured, and untextured.
- 13. A laminated semiconductor article in accordance with claim 8 wherein said oxide buffer system further comprises at least one material selected from the group consisting of perovskite, MgO, CeO<sub>2</sub>, Y<sub>2</sub>O<sub>3</sub>, SrTiO<sub>3</sub>, BaZrO<sub>3</sub>, BaSnO<sub>3</sub>, BaCeO<sub>3</sub>, YSZ, (RE<sub>1-x</sub>Sr<sub>x</sub>)MnO<sub>3</sub>, REMnO<sub>3</sub>, RE<sub>2</sub>O<sub>3</sub>, REAlO<sub>3</sub>, RE<sub>2</sub>Zr<sub>2</sub>O<sub>7</sub>, RE<sub>3</sub>NbO<sub>7</sub>, RESMO, and REMO where RE comprises at least one rare-earth element.

- 14. A laminated semiconductor article in accordance with claim 8 wherein said Ir buffer layer further comprises the alloy Ir<sub>1-x</sub>M<sub>x</sub> wherein M comprises at least one element selected from the group consisting of Ta, Ti, Cu, Pt, Pd, Ru, Rh, W, Os, Au, and Ag.
- 15. A laminated semiconductor article in accordance with claim 8 wherein said semiconductor comprises diamond.
- 16. A laminated semiconductor article comprising:
  - a. a flexible Ir-based substrate; and
  - b. at least one epitaxial layer of a semiconductor on said flexible Ir substrate.
- 17. A laminated semiconductor article in accordance with claim 16 wherein said flexible Ir substrate further comprises the alloy Ir<sub>1-x</sub>M<sub>x</sub> wherein M comprises at least one element selected from the group consisting of Ta, Ti, Cu, Pt, Pd, Ru, Rh, Os, Au, and Ag.
- A laminated semiconductor article in accordance with claim 16 wherein said semiconductor comprises diamond.
- 19. A laminated semiconductor article in accordance with claim 16 wherein said article further includes at least one buffer layer between the Ir-based layer and said semiconductor, said buffer layer comprising at least one material selected from the group consisting of nitrides, perovskites, MgO, CeO<sub>2</sub>, Y<sub>2</sub>O<sub>3</sub>, SrTiO<sub>3</sub>, BaZrO<sub>3</sub>, BaSnO<sub>3</sub>, BaCeO<sub>3</sub>, YSZ, (RE<sub>1-x</sub>Sr<sub>x</sub>)MnO<sub>3</sub>, REMnO<sub>3</sub>, RE<sub>2</sub>O<sub>3</sub>, REAlO<sub>3</sub>, RE<sub>2</sub>Zr<sub>2</sub>O<sub>7</sub>, RE<sub>3</sub>NbO<sub>7</sub>, RESMO, and REMO where RE comprises at least one rare-earth element,.